



European Society for Experimental Mechanics

We are inviting applications for 10 conference attendance awards for PhD students or postdoctoral fellows to attend the 20th International Conference on Experimental Mechanics in Porto, Portugal, July 2-7, 2023. The applications will be assessed by an evaluation committee chaired by the president of EuraSEM, Professor Zbigniew Kowalewski.

EURASEM – ICEM20 CONFERENCE ATTENDANCE AWARDS 2023

Eligibility criteria

1. The applicant must be a PhD student for at least 2 years or a postdoctoral fellow for not more than 1 year.
2. Each **department** can only submit one application, should EURASEM receive 2 applications from the same department, only the first application received will be taken into consideration (if eligible) and a letter will notify other candidates that unfortunately they are not eligible. Hopefully, each department will coordinate the submission.
3. The applicant must have his/her original work approved for oral presentation in ICEM20 and has completed his registration for the conference as “Student Delegate”.

Applicants should provide before June 12, 2023:

1. An updated Curriculum Vitae and recommendation letter from his/her promotor.
2. The candidate should provide an active registration at a university.
3. A description of the research work (max 5 pages) highlighting the scientific challenges, the methodology and the innovative aspects related to experimental mechanics.

Selection criteria

All eligible applications will be reviewed by the evaluation committee chaired the president of EuraSEM. From the final ranking, the first ten applications from **different countries** will be granted.

Award

For the 10 award winners the full value of the early-bird registration fee will be reimbursed by EURASEM. Additionally, accommodation expenses will be reimbursed up to a max of 200€.

All applications should be sent by e-mail to the following persons:

President of EuraSEM: zkowalew@ippt.pan.pl

Secretary of EuraSEM: blazej.skoczen@pk.edu.pl